

Electronic Patent Application Fee Transmittal

Application Number:	10082593			
Filing Date:	22-Feb-2002			
Title of Invention:	Semiconductor device inspection method			
First Named Inventor/Applicant Name:	Akira Hamamatsu			
Filer:	John J Farrell/Cindy Morton			
Attorney Docket Number:	16869P-041800US			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Petition-revive unintent. abandoned appl	1453	1	1500	1500
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				2290